

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Response Under 37 CFR 1.116 - Expedited Procedure  
 :Customer Number: 20277

Toshikazu ONISHI : Confirmation Number: 5515  
 Application No.: 10/665,469 : Group Art Unit: 2828  
 Filed: September 22, 2003 : Examiner: Phillip Nguyen

For: SEMICONDUCTOR LASER DEVICE AND METHOD FOR FABRICATING THE SAME

Mail Stop AF  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.  
 Applicant is entitled to small entity status under 37 CFR 1.27  
 Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	11	20	0	\$50.00 =	\$0.00
Independent Claims	5	5	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented				\$0.00	
Fee for extension of time				\$0.00	
				\$0.00	
Total of Above Calculations				\$0.00	

Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty  
 Registration No. 36,139

Please recognize our Customer No. 20277 as our correspondence address.

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 WDC99 1328391-1.060188.0660



JKW AF



Docket No.: 060188-0660

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshikazu ONISHI

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE

Application No.: 10/665,469

Customer No.: 20277

Filed: September 22, 2003

Confirmation No.: 5515

Group Art Unit: 2828

Examiner: Phillip Nguyen

Title: SEMICONDUCTOR LASER DEVICE AND METHOD FOR FABRICATING THE SAME

**AMENDMENT UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated September 26, 2006, pursuant to the provisions of 37 C.F.R. § 1.116.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.